

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Yuh-Fong Hwang

Serial No.: 10/792,246

Filed: March 3, 2004

For: METHOD AND SYSTEM FOR
MASK FABRICATION PROCESS
CONTROL

Confirmation No. 3979

Group Art Unit: 2125

Examiner: Cabrera, Zoila

TKHR Ref. 252011-1950

Top-Team Ref. 0503-A30088US

RESPONSE TO OFFICE ACTION

Mail Stop: Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

The Office Action mailed December 22, 2006 has been carefully considered. In response thereto, Applicant submits the following remarks.